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ON <u>OCTOBER 25, 2007</u>

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Granik et al.

**Application No. 09/898,431** 

Filed: July 2, 2001

Confirmation No. 1914

For: METHOD OF COMPENSATING FOR

ETCH EFFECTS IN

PHOTOLITHOGRAPHIC PROCESSING

Examiner: Thomas H. Stevens

Art Unit: 2121

Attorney Reference No. 1011-78093-02

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## AMENDMENT AND REQUEST FOR RECONSIDERATION

This responds to the Office action dated July 25, 2007. Please amend the referenced application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2.

Remarks begin on page 7.